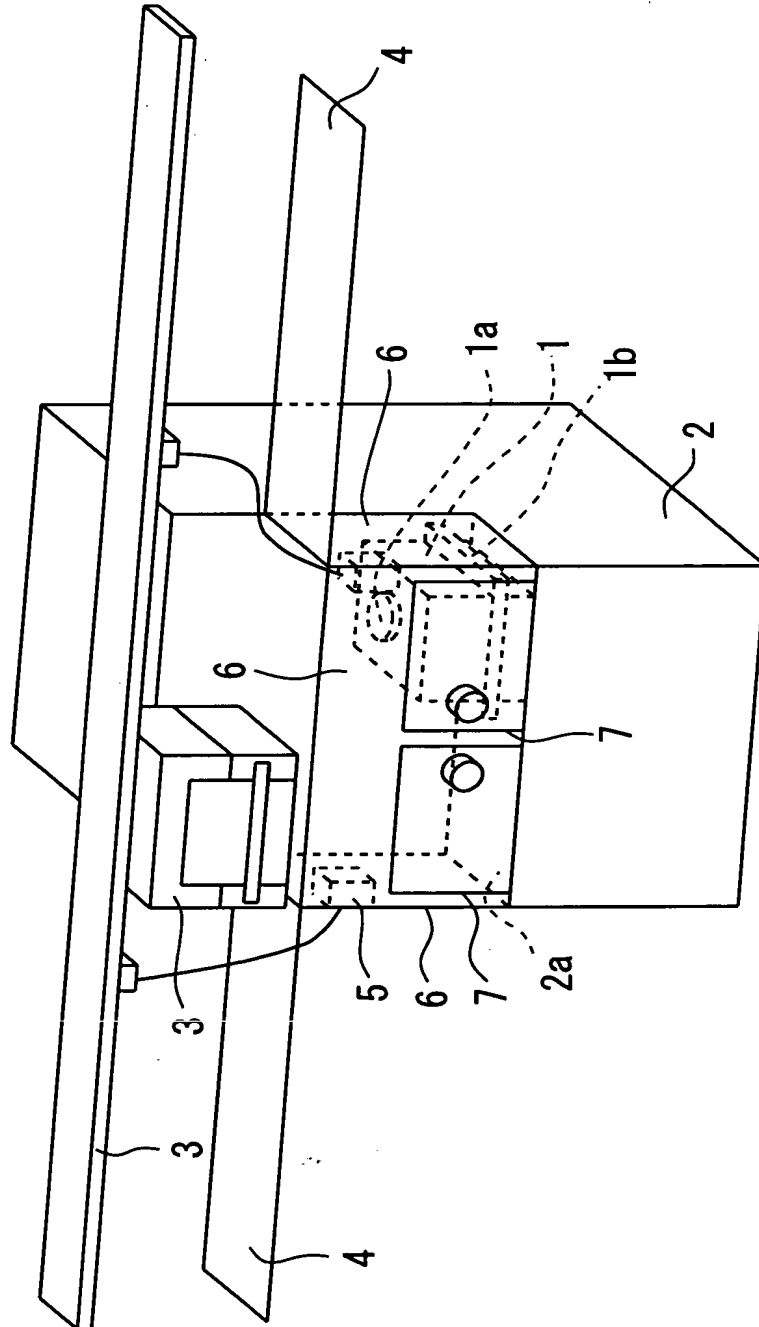


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2 FGS

Fig. 1



Title: SUBSTRATE PROCESSING
APPARATUS, SUBSTRATE PROCESSING
SYSTEM, AND SUBSTRATE CONVEYING
METHOD

Inventor(s): Shinyo KIMOTO et al.
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Fig. 2

